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# *In-operando* adjustable orbital polarization in LaNiO<sub>3</sub> thin films

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## Abstract

The different occupancy of electronic orbitals, the so-called *orbital polarization*, is a key parameter determining electric and magnetic properties of materials. Here we report on the demonstration of *in-operando* voltage-controlled tuning of the orbital occupation in LaNiO<sub>3</sub> epitaxial thin films grown on piezoelectric substrates. The different static contributions to the orbital occupation are disentangled, namely the epitaxial strain and the surface symmetry breaking, and the superimposed electric-field controlled orbital polarization is determined by x-ray linear dichroism at the Ni-L<sub>2,3</sub> edges. The voltage-controlled orbital polarization allows changing the orbital polarization by about an additional 50%.



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#### I. INTRODUCTION

Manipulating the 3*d* orbital states in transition-metal oxides opens a way to create artificial materials by design. One can envision, for instance, the possibility of engineering materials which emulate the electronic and orbital configuration of high temperature superconductors (HTSc) [1-3]. Nickelate perovskite *R*NiO<sub>3</sub> (*R* is a trivalent rare earth ion), and in particular LaNiO<sub>3</sub> (LNO) (the only compound in the series showing metallic behaviour at all temperatures) [4], are promising candidates for this purpose. The electronic structure of Ni<sup>3+</sup> is composed of a full  $t_{2g}$  band and a single electron occupancy in the  $e_g$  states  $(3d^7: t_{2g}^6 e_g^1)$  which - due to the essentially isotropic 3D character of the Ni-O bonding network in bulk compounds - are degenerate. On the other hand, cuprate HTSc show a Cu<sup>2+</sup>:  $3d^9$  configuration where, due to the 2D layered structure, the  $e_g$  states are 100% orbitally polarized, *i.e.*, the single hole is located in a  $x^2-y^2$  state of the crystal-field-split  $e_g:(z^2, x^2-y^2)$ -manifold. Achieving such an analogous configuration in LNO would require lifting the Ni<sup>3+</sup> 3d- $e_g$  orbital degeneracy. This could eventually result in a preferential electron occupancy of one of the  $e_g$  orbitals, thus giving rise to a large 'orbital polarization' (henceforth, abbreviated as 'OP') of the *d* states forming the conduction band.

Different ways have been explored to modulate the OP in nickelates: (*i*) strain engineering [5,6] (*ii*) electron confinement by sandwiching LNO layers between insulating layers [6] and (*iii*) charge transfer in trilayer heterostructures, mimicking to some extent the role of free surfaces, or inversion symmetry breaking [7], as recently reviewed by Disa *et al.* [8].

The strain-induced modulation of orbital occupancy has been proven to be effective in manganite thin films [9,10] as well as in the nickelates [5,6], leading to a preferential  $x^2-y^2$   $(3z^2-r^2)$  occupancy for tensile (compressive) strain. Substrate-induced epitaxial strain can be accommodated by tetragonal distortion of the coordination polyhedra of the metal ions as well as by octahedral rotations, their relative role can be different for the compressive or tensile strain [11] and it could thus lead to asymmetric effects of strain on OP. Indeed, early results suggested an intriguing asymmetric response of OP to tensile/compressive elastic strain in LNO films [4]; however, it was later argued that this difference in orbital polarization could be related to the contribution of surface states rather than elastic strain, which originates from symmetry breaking at the free surface [5], as already reported in manganite films [10] and other similar systems [12,13].

In bilayer structures, such as LaNiO<sub>3</sub>/LaAlO<sub>3</sub> superlattices [6] - where ultrathin LNO films are confined between the LaAlO<sub>3</sub> insulating layers - the charge hopping along the *z*-direction (i.e., perpendicular to the NiO<sub>2</sub> planes) is cancelled, thus producing a narrowing of the electronic bandwidth associated to the  $z^2$  orbitals. Therefore, subsequent filling of the 3*d* orbitals should shift the Fermi level towards the  $x^2-y^2$  band, thus increasing the OP. Experimental results on LaNiO<sub>3</sub>/LaTiO<sub>3</sub> superlattices have confirmed this view [7]. This charge transfer also promotes the appearance of an electric field that expands the Ni-O-Ti bonds along the *z*-axis which pushes further down the  $z^2$  orbital, causing an enhanced OP. It was predicted that OP could be ultimately raised by including the symmetry breaking of the Ni coordination polyhedra in the tricolor superlattice LaTiO<sub>3</sub>/LaNiO<sub>3</sub>/LaAlO<sub>3</sub>. Combining the strain and confinement could lead to a change of OP by about 25 % [6], whereas the symmetry-breaking superlattices promised OP of 55% , which is in good agreement with experiments [7].

All in all, in the LNO heterostructures summarized above, the orbital occupancy is determined by a combination of the electronic properties of the materials sandwiching the LNO film, the internal polar fields acting on the LNO layer, and/or the epitaxial strain imposed by

the substrates. Therefore, the design of LNO heterostructures determines OP and ultimately fixes the electronic properties of the LNO films.

Aiming at the development of reconfigurable devices, it would be highly desirable to design oxide-based systems where OP can be tuned in-situ by using an appropriate stimulus. To this goal, here we report on orbital polarization in LNO films grown on piezoelectric substrates (e.g.  $Pb(Mg_{1/3}Nb_{2/3})O_3$ -PbTiO<sub>3</sub> (PMN-PT)). Piezoelectric substrates, based on the converse piezoelectric effect, allow a voltage-controlled deformation of the material. If an active layer is suitably grown and epitaxially clamped to a piezoelectric substrate, a voltage-controlled strain can be transmitted to the functional film and so its properties can be tailored *ad hoc*. This approach has been extensively used, for example, to modulate the magnetic properties of metals and oxides, namely the magnetization and magnetic anisotropy [14-16] as well as to tune the metal-insulator transitions in manganites [17] and vanadates [18]. This approach has been recently used to attempt the tuning of the temperature ( $T_{MI}$ ) of the metal-insulator (M-I) transition of NdNiO<sub>3</sub> thin films [19].

Besides this piezo-strain action/response, it worth noticing that piezo electric substrates under applied voltage, may also influence an upper laying film via the presence of polarization charges. Therefore, piezo substrates could allow, in principle, to emulate the electric field existing in tricolor superlattices and take advantage of the polarization-related interfacial bonding [20], with the additional benefit that these effects become controllable *in-situ* by an external voltage.

In this paper, we explore the orbital polarization of epitaxial LNO thin films, with the ultimate goal of achieving a large and in-situ tunable orbital polarization. We exploit the wellknown sensitivity of linearly polarized x-ray absorption spectroscopy (XAS) at transition-metal L<sub>2,3</sub> absorption edges and the x-ray linear dichroism (XLD) as a probing tool for determining the OP. Earlier experiments on manganite films grown on ferroelectric/piezoelectric substrates have demonstrated that using XLD, one can determine voltage-induced changes of orbital polarization of 3d states. For instance, D. Preziosi et al. [21] have reported the XLD data at the Mn-L<sub>2,3</sub> edges of La<sub>0.825</sub>Sr<sub>0.175</sub>MnO<sub>3</sub> films grown on ferroelectric PbZr<sub>0.52</sub>Ti<sub>0.48</sub>O<sub>3</sub> (PZT) and observed a change of orbital occupation depending upon the polarization state of the ferroelectric layer. It was argued that this observation was due to the changes of Mn-O-Mn bonds at the interface which are distinct for up/down polar states of the ferroelectric substrate. Heidler et al. [22] reported the XLD on La<sub>0.7</sub>Sr<sub>0.3</sub>MnO<sub>3</sub> films grown on PMN-PT(011) and observed a change of orbital occupation under the electric-field biasing, which was attributed to the elastic response of the magnetic layer to the piezo deformation of the substrate. Interestingly, similar experiments performed on Co/PMN-PT(011) suggested that the most relevant effects are related to polarization-induced charge reconstruction, rather than to strain, at the electrode (Co) [23]. These few examples illustrate the complexity of the problem.

Our paper is organized as follows. To establish a self-contained starting point, we first monitor the impact of epitaxial strain on OP, by determining the OP in LNO films grown on various substrates imposing different epitaxial strain. Next, in order to disentangle the unavoidable contribution of symmetry-breaking at the free surface of the films on OP, we report measurements on LNO films of different thicknesses but having a constant strain state. Armed with this knowledge, we proceed next to determine OP in LNO films grown on piezo substrates (PMN-PT) and its dependence on the electric field biasing the substrate, by measuring the XLD at the Ni-L<sub>2,3</sub> edges at *in-operando* conditions. Our data show a dramatic control of OP by the voltage, which mimics the piezo-deformation of the substrate. Interestingly, the voltage-induced changes of the orbital occupancy are found to be much larger (about a fivefold increase) than those expected on the basis of an elastic deformation induced

by a potential clamping of the LNO film to the underlying piezoelectric PMN-PT substrate. Several scenarios are analyzed to address this giant sensitivity of LNO orbital polarization to the voltage-induced substrate piezo-response; we argue that this enhanced response may be a signature of either the known distinctive piezoelectric properties of PMN-PT surfaces or result from a genuinely different response of the LNO lattice to epitaxial strain induced during high temperature film growth and possible room-temperature dynamic substrate-induced deformations. In any event, it will be shown that although polarization can be voltage-tuned by about  $\Delta P/P = 66$  % [where *P* is defined as 3*d* orbital polarization], the most critical observations are that the absolute values of *P* remain within a 8% to 3% range and that the voltage-controlled term favors a  $3z^2-r^2$  occupation that competes with the PMN-PT epitaxial mismatch favoring the  $x^2-y^2$  occupancy, thus challenging achieving the much desired full  $x^2-y^2$  occupation. To this respect, we propose some strategies that may allow reverting the competition among epitaxial-strain and piezo-controlled orbital polarization contributions.

#### **II. EXPERIMENTAL DETAILS**

We grew epitaxial LNO films on various single-crystalline substrates by pulsed laser deposition (PLD) at an oxygen pressure of 0.15 mbar and a substrate temperature of 700°C. The number of laser pulses was varied to obtain films with nominal thickness *t* between 2 and 14 nm, according to the growth rate calibration. For every given number of laser pulses, films on different substrates were grown simultaneously to minimize spurious thickness variations. We used single-crystalline substrates with (001)-orientation having a (pseudo)cubic lattice parameter either smaller [in case of LaAlO<sub>3</sub> (LAO)] or larger [for (LaAlO<sub>3</sub>)<sub>0.3</sub>-(Sr<sub>2</sub>AlTaO<sub>6</sub>)<sub>0.7</sub> (LSAT) and SrTiO<sub>3</sub> (STO)] than the pseudo-cubic parameter of LNO (mismatch values are given in **Table I**). Similarly, 10 nm thick LNO films were grown on bare PMN-PT(001) substrates and also on STO-buffered (5 nm) PMN-PT(001) substrates.

The structural characteristics of the LNO films were investigated by x-ray diffraction (XRD) using the  $\theta$ -2 $\theta$  patterns for determining the out-of-plane cell parameters and grazing incidence scans for the in-plane cell parameters via in-plane (220) reflections and reciprocal space maps. Further growth and structural characterization details can be found in Ref. [24]. The biaxial tensile strain promoted by the cubic (or nearly-cubic) substrates induces a contraction of the *c*-axis lattice parameter for films grown on STO and LSAT, while the films on LAO show an out-of-plane lattice parameter larger than bulk LNO, as expected from compressive strain-induced tetragonal distortions of the films. The out-of-plane lattice parameters (c) of the films were determined by doing XRD simulations taking into account the interference effects between the diffracted waves from films and substrates [25]. The bestfitting curves lead to the *c*-values given in **Table I**. The in-plane cell parameters (*a*) extracted from grazing-incidence XRD experiments are also included in Table I. For completeness we also include in Table I, the XRD data of the LNO films on PMN-PT to be discussed latter, as well as the calculated structural mismatch and the in-plane strain measured on all films. Within our diffractometer resolution, and in good agreement with previous reports [24], we have found in the reciprocal space maps no evidence of extra peaks which may indicate a lower-thantetragonal symmetry (i.e. monoclinic). Details on structural characterization are in the **Supplementary Information S1.** 

All LNO films reported here display a metallic behavior, with room-temperature resistivities  $< 0.9 \text{ m}\Omega \text{cm}$  and  $< 3 \text{ m}\Omega \text{cm}$  for thicknesses of 14 nm and 2 nm, respectively (Supplementary Information S1).

Substrate	Mismatch* (%)	<i>a</i> (Å)	c (Å)	Strain (ε) <sup>♥</sup> (%)
STO	+1.96	3.89	3.80	+1.57
LSAT	+0.99	3.86	3.82	+0.78
LAO	-1.12	3.80	3.91	-0.78
PMN-PT	+5.17	3.87*	3.78	+1.0*
*Mismatch = $(a_{sub} - a_{LNO})/a_{LNO}$			$a_{LNO} = 3.83 \text{ Å}$	
•Strain = $(a_{film} - a_{LNO})/a_{LNO}$				
*Determined from reciprocal space maps of LNO(10 nm)/STO(5 nm)//PMN-PT				

**Table I.** Lattice parameters (a, c), mismatch (in %), and in-plane strain  $(\varepsilon)$  (in %) values for LNO films grown on various substrates. Positive and negative signs correspond to in-plane tensile and compressive lattice mismatch and strain, respectively.

We measured the XAS of the samples at the Ni-L<sub>2,3</sub> edges at 300 K using linearly (either horizontal or vertical) polarized light and probed the XLD as the difference between the two light polarizations. To get access to the subtle differences in the orbital occupancy of  $e_{g}$ - $(x^2-y^2)$ and  $3z^2 - r^2$ ) states, the x-ray absorption has to be taken for E//ab and for E//c (later shortened as  $E_{ab}$  and  $E_c$ , respectively, where *ab* and *c* indicate in-plane and out-of-plane x-ray electric field *E* directions, respectively). Due to geometrical constraints, following common practice, we collected the spectra in grazing incidence with the x-rays incidence direction k at  $\theta = 60^{\circ}$ with respect to the surface normal. Thus, the light polarization vector E is parallel (vertical polarization) or nearly perpendicular (horizontal polarization) to the film surface normal. The geometric effect due to the non-fully grazing incidence ( $\theta = 60^{\circ}$ ) is corrected in the determination of P as described in Refs. [26] and [27]. The photocurrent was measured in the total electron yield (TEY) mode. XAS data in TEY mode can be robustly collected at 300 K and at low temperature (Supplementary Information S2), confirming the metallic nature of the LNO films. Average XAS spectra were obtained by averaging the intensities of both linear polarizations - parallel to the surface normal,  $I(E_c)$ , and perpendicular to it,  $I(E_{ab})$  - as  $I_0=[I(E_c)+I(E_{ab})]/2$ . The XLD signal was obtained as  $I(E_{ab})-I(E_c)$ . The XAS experiments were performed at two different synchrotrons: (i) 'substrate-induced strain'- experiments at BACH [28], Elettra light source (Italy) and (*ii*) 'electric field-controlled strain' experiments at BL29 BOREAS [29], ALBA synchrotron (Spain), using a specially designed set-up.

In lanthanum nickelates, the La-M<sub>4</sub> absorption edge overlaps with the pre-edge side of the Ni-L<sub>3</sub> edge [see **Supplementary Information S3**]. We have removed this La-M<sub>4</sub> contribution by subtracting the La-M<sub>4</sub> spectra measured on La-containing perovskite oxides, either LaCoO<sub>3</sub> (Elettra) or La<sub>2/3</sub>Sr<sub>1/3</sub>MnO<sub>3</sub> (LSMO) (ALBA), during the experiments. After subtracting these reference spectra, the Ni-L<sub>3</sub> peak splitting and the Ni-L<sub>3</sub> XLD remain unaffected. On the other hand, the Ni-L<sub>2</sub> edge is not affected at all by the La overlapping.

In **Figure 1(a)** we show, as an illustrative example, the Ni-L<sub>2,3</sub> XAS of a LNO film after subtracting the La-M<sub>4</sub> peak. It can be appreciated that the resulting Ni spectra are in close agreement with the reported spectra for Ni<sup>3+</sup> oxides (see Refs. [30-33]). A detailed inspection of the Ni-L<sub>3</sub> edge reveals a double peak structure (**Supplementary Information S3**) whose energy splitting and relative intensities are related to the Ni-O hybridization strength [31-33] which will not be discussed here. The Ni-XLD cannot be affected by the La-M<sub>4</sub> because the symmetric  $4d^{10}5s^25p^6$  electronic configuration of La<sup>3+</sup> produces a null XLD contribution. Therefore, the XLD provides reliable information on the 3*d* electron orbital occupancy within the  $x^2-y^2$  and  $3z^2-r^2$  states of the Ni<sup>3+</sup>  $e_g$ -manifold ( $d^7$ :  $t_{2g}{}^6e_g{}^1$ ). The hole ratio (X) of unoccupied final  $e_g$  states (ratio of  $3z^2-r^2$  to  $x^2-y^2$ ) can be determined by using the integrated intensities  $I_c$  and  $I_{ab}$  of the Ni- $L_{2,3}$  edges (excluding the La-overlapping vicinities, as shown in **Figures 1(a,b)**) and is given by [26]:

$$X = \frac{h_{3Z^2 - r^2}}{h_{x^2 - y^2}} = \frac{3I_c}{4I_{ab} - I_c} \tag{1}$$

where  $h_i$  is the hole concentration corresponding to the  $3z^2-r^2$  or  $x^2-y^2$  orbitals, and  $I_c$  and  $I_{ab}$  are the integrals of the XAS spectra  $I(E_c)$  and  $I(E_{ab})$  within the light cyan-coloured region of **Figures 1(a,b)** after removing the background by taking a step function. The 3*d* orbital polarization, *P*, is defined as:

$$P = \frac{\left(n_{x^2 - y^2}\right) - \left(n_{3z^2 - r^2}\right)}{\left(n_{x^2 - y^2}\right) + \left(n_{3z^2 - r^2}\right)} = \left(\frac{4}{n_{eg}} - 1\right) \left(\frac{X - 1}{X + 1}\right) \tag{2}$$

where  $n_i$  represents the electron occupancy at the corresponding  $3z^2-r^2$  and  $x^2-y^2$  orbitals. The 'P' can be rewritten in terms of the experimental observable 'X' as indicated; here  $n_{e_g}$  represents the total number of electrons at the Ni  $e_g$ -orbitals, that in the simplest ionic picture (Ni<sup>3+</sup> =  $3d^7$ ) would correspond to  $n_{e_g} = 1$ . However, we stress that 'X', rather than 'P', is the experimental observable in XLD data [34].



**Figure 1. (a) and (b)** Ni-L<sub>2,3</sub> XAS (for E||c and E||ab polarizations) of 14 nm LNO thin films on STO and LAO, respectively. The spectra are plotted after subtracting the La-M<sub>4</sub> and normalizing to their average L<sub>3</sub> peak intensity (E<sub>0</sub>). (c) The Ni-L<sub>2,3</sub> XLD (i.e., E||ab minus E||c) of LNO(14 nm) films grown on different (001)-oriented single crystalline substrates indicates that the STO and LAO (tensile and compressive-strained) exhibit opposite signs corresponding to the  $x^2-y^2$  and  $3z^2-r^2$  orbital occupancy, respectively, while the LSAT remains intermediate. (d) The Ni-L<sub>2,3</sub> XLD of 2, 5, and 14 nm LNO on STO indicate that the sign and magnitude of XLD changes, indicating a larger  $3z^2-r^2$  orbital occupancy when reducing thickness. (e) The O-K edge XAS for different thicknesses of LNO films on STO substrates. (f) Thickness variation of the O-K XLD for the LNO films on LAO, LSAT, and STO substrates.

#### **III. RESULTS AND DISCUSSION**

We start the discussion with the first part of the results, *i.e.* the substrate-induced elastic strain effects on the Ni 3d orbital polarization derived from the XLD data. To this purpose, we have used LNO films with 2, 5, and 14 nm thicknesses on various (001)-oriented single crystalline substrates (causing either tensile or compressive strain). In **Figure 1(c)** we show the Ni-L<sub>2,3</sub> XLD spectra of 14 nm-thick LNO films under different epitaxial strain. The XLD data are plotted after normalizing the spectral weight of the corresponding isotropic XAS to one at the L<sub>3</sub> peak, as shown in **Figs. 1(a)** and (b) for LNO films on STO and LAO, respectively. It can be readily appreciated from the above data that the LNO film grown on the LAO substrate (compressively strained) shows a positive XLD signal at both L<sub>2</sub> and L<sub>3</sub> edges. This indicates a larger x-ray absorption for the in-plane oriented orbitals (larger  $h_{x^2-y^2}$ ) than for the out-ofplane ones ( $h_{3z^2-r^2}$ ). In contrast, the LNO film on STO (tensile strained) displays a clearly negative XLD signal (*i.e.* more available states in the out-of-plane  $3z^2-r^2$  orbitals). The sample on LSAT (slight tensile strain) shows intermediate, barely positive, XLD signal. Overall, the XLD spectra immediately reflect the 3d orbital occupancy.

As aforementioned, by taking  $I_c$  and  $I_{ab}$  we have evaluated the hole occupancy ratio 'X', as given in eq (1), as a function of strain (see Figure 2(a), black dots and lines for the 14 nmthick films). The bottom x-axis shows the in-plane strain ( $\varepsilon$ ) - either positive (LSAT, STO) or negative (LAO) - acting on the LNO films. For convenience, we include in Figure 2(a) (right axis) the orbital polarization, P, calculated by assuming  $n_{e_g} = 1$ . It can be observed that  $X(\varepsilon)$ increases with  $\varepsilon$  indicating that the  $h_{3z^2-r^2}/h_{x^2-y^2}$  ratio increases with the tensile strain, reflecting a strain-induced stabilization (and thus higher electron occupancy) of the  $x^2-y^2$ states; reciprocally, X decreases when increasing the compressive strain, reflecting the straininduced stabilization (and thus larger electron occupancy) of the  $3z^2 - r^2$  orbitals. Interestingly, however, the overall trend appears to be shifted downwards (see the dashed line with vellow arrows in Figure 2(a)). Indeed, for a nominally strain-free film ( $\varepsilon = 0$ ), Figure 2(a) indicates that P would be different from zero (*i.e.* X < 1) thus indicating that the  $3z^2 - r^2$  orbitals are stabilized even when the epitaxial strain is absent ( $\varepsilon = 0$ ). As already noticed in manganite thin films [10], this effect originates from the absence of apical oxygen atoms in the surface layers. To assess this scenario in nickelates, we have grown LNO films down to 2 nm thickness on each substrate, expecting to enhance the surface contribution in the thinner films.

In Figure 1(d), we compare the XLD data of 2, 5, and 14 nm-thick LNO films grown on STO substrates. It is clear that, when reducing the film thickness, the XLD signal (both at the L<sub>2</sub> and the L<sub>3</sub> edges) becomes gradually more positive. This is reflected by a corresponding X reduction, as shown by the thickness-dependent  $X(\varepsilon)$  data of Figure 2(a). In other words, electrons within the free surface are preferentially localized at  $3z^2-r^2$  orbitals, *i.e.* the  $3z^2-r^2$ orbitals are pushed down in energy due to the symmetry breaking at the LNO surface. Therefore, the above data can be interpreted as follows: In the thicker films - where the bulk contribution of the film dominates the dichroic signal(s) - mostly strain effects (the so-called strain-induced orbital polarization) determine the measured orbital occupancy. However, when reducing the sample thickness, the signal originated at surface layers becomes more relevant and the XLD is dominated by the surface symmetry-breaking effects. To summarize, the tensile strained films show a positive P in the bulk regime, as expected from the strain effects, but a negative polarization emerges at the surface [see Figure 2(a)].



**Figure 2.** (a) Hole ratio (*X*) (left-axis) and electron orbital polarization (*P*) (right-axis) as a function of substrate-induced epitaxial in-plane strain ( $\varepsilon$ ) for the LNO films (2, 5, and 14 nm) on different strains (tensile for STO and LSAT, compressive for LAO). Dashed oblique line passing through the origin ( $\varepsilon = 0, X = 1$ ) indicates the apparent orbital polarization if strain-only phenomena were considered. However, the yellow arrows illustrate the observed downward shift in *X* due to the symmetry-breaking at surface-induced ( $3z^2-r^2$ ) orbital polarization. (b) The *X* and *P* values of LNO film in LNO(10nm)/STO(5nm)//PMN-PT heterostructure as a function of the voltage ( $V_{bias}$ ) applied across the PMN-PT substrate (bottom-axis). Top-axis show the maximal possible in-plane (tensile) strain caused by the STO//PMN-PT at some selected  $\pm V_{bias}$  values, assuming a fully elastic response of LNO to PMN-PT deformation.

A similar thickness dependent XLD analysis has been performed on all the LNO films (2, 5 and 14 nm) grown on other substrates (LSAT and LAO) (see Supplementary Information S4). In Figure 2(a) we have plotted all the measured X and calculated P values as a function of both strain and thickness. An inspection of all these data confirms that, irrespective of the substrate, there is a similar enhancement of the  $3z^2-r^2$  occupancy at the surface of all the LNO films. A final test of this hypothesis has been performed by measuring the XLD of a LNO film that has been *on-purpose* grown and *in-situ* capped with a layer of LAO to avoid surface contamination. As expected, the  $3z^2-r^2$  contribution associated to the symmetry-breaking at the surface is found to be reduced (see Supplementary Information S5).

To convey a clear message, we have so far assumed a purely ionic picture for the Ni-O bond, that is: Ni<sup>3+</sup>-2p<sup>6</sup> electronic configuration. However, it is known that the wavefunction for 3d-Ni in a Ni-O octahedron can be written as  $\Phi_g = \alpha |3d^7\rangle + \beta |3d^8\underline{L}\rangle$ , where  $|\underline{L}\rangle$  indicates a hole in the O-2p band,  $\alpha^2 + \beta^2 = 1$  and  $\beta \gg \alpha$  [35]. Therefore, it should be expected that the XAS at the O-K edges also reflects the impact of strain and surface effects on the hybridization strength ( $\beta$ ). Similarly, the selective occupation at the Ni-e<sub>g</sub> orbitals derived above should translate into a selective occupancy of the corresponding ( $p_{x_0,y_2}$ ) hybridized states, which may give rise to an observable XLD at the O-K edges. Both features have been identified here through the analysis of the XAS and XLD at the oxygen K edge, particularly on the pre-peak edges, which are most sensitive to the Ni 3d-O 2p hybridization. Figure 1(e) illustrates the evolution of the O-K edge pre-peak of LNO/STO with LNO thickness and in Figure 1(f) we depict the XLD determined at O-K edge pre-peak as a function of substrate and thickness. Quantitative analysis of these signals is challenged by the contribution of the substrate, that become relevant when reducing the thickness of LNO (**Supplementary Information S6**).



**Figure 3.** (a) Sketches illustrating the orbital polarization definitions. (b) and (c) Orbital polarization induced by compressive and tensile strain, respectively. (e) Surface-induced orbital polarization acting on a degenerate  $e_g$  orbital manifold (d)

One can observe in **Figure 2(a)** that epitaxial strain allows modifying the orbital polarization by as much as  $\Delta X \approx 13 \%$  ( $\Delta P \approx 20 \%$ ), corresponding to  $\Delta X/\Delta \varepsilon \approx 6 \%/\%$  ( $\Delta P/\Delta \varepsilon \approx 9 \%/\%$ ). This variation is in good agreement with the results ( $\Delta X/\Delta \varepsilon \approx 9.5\%/\%$ ) reported for (LNO/ABO<sub>3</sub>)<sub>4uc</sub> superlattices [6]. From these observations, we assess that the strain stabilizes indistinctly both the  $3z^2-r^2$  and  $x^2-y^2$  states and thus the occupancy ratio ( $h_{3z^2-r^2}/h_{x^2-y^2}$ ) can

be regulated. However, one should notice that the measured values of the orbital polarization are rather modest. Indeed, full occupation of  $x^2-y^2$  orbitals corresponds to X = 2 (P = 1), as sketched in **Figure 3(a)**. The measured orbital polarization values roughly span from  $X \approx +0.9$  to 1.05 (-16 % < P < 8%), as illustrated in **Figure 3(b,c**).

Now, we discuss the second part of our work, concerning the effect of electric fieldinduced elastic strain on the Ni 3d orbital polarization. Here, we have used LNO films with intermediate thickness (10 nm) on the piezo-substrate (PMN-PT) buffered with an STO layer (5 nm). While LNO films had been first grown directly on PMN-PT their polycrystalline nature (Supplementary Information S1) precluded further use and we thus concentrate on the LNO films grown using the STO buffer layer. The XRD data reveal that the STO buffer film grown on PMN-PT exhibits, within the experimental resolution, the bulk STO cell parameters; therefore, as we have already described in the aforementioned substrate-induced elastic strain experiments, the LNO film is tensile strained (see data in Table I and the experimental results in Supplementary Information S1). In Figure 4(a) we show a sketch illustrating the experimental arrangement for recording the XAS with an external bias voltage ( $V_{\text{bias}}$ ) applied across the sample (LNO/STO//PMN-PT) perpendicular to the sample substrate. Briefly, a copper plate attached below the substrate was used as a bottom electrode. The metallic LNO film, was connected, via a tee, to a grounded electrometer to record the TEY signal and to a DC power supply (battery box - up to  $\pm 200$  V) to apply a V<sub>bias</sub> across the PMN-PT, using LNO film and the copper plate underneath the substrate as top and bottom electrodes, respectively, as shown in the Figure 4(a).



**Figure 4.** (a) Sketch of the experimental arrangement to measure the XAS absorption in a voltagebiased LNO/STO//PMN-PT heterostructure. (b) The raw TEY signal at Ni-L<sub>2,3</sub> edges collected with  $V_{\text{bias}} = -200 \text{ V}$ , 0 V and +200 V. (c,d,e) The Ni-L<sub>2,3</sub> XAS recorded at  $V_{\text{bias}} = -200 \text{ V}$ , 0 V, and + 200 V, respectively, using polarizations  $\mathbf{E}_{ab}$  and  $\mathbf{E}_{c}$  as indicated, after subtracting La-M<sub>4</sub>. Insets in (c,d,e) are zooms of the L<sub>3</sub> peak data recorded with  $\mathbf{E}_{ab}$  and  $\mathbf{E}_{c}$ , where dichroism is more evident. Integrated XAS values were taken from the light cyan-colored region after removing the step-function.

The XAS data at the Ni-L<sub>2,3</sub> edges were collected with  $E_{ab}$  and  $E_c$  x-ray polarizations, similarly to the previous experiment, but using the *in-situ* applied  $V_{\text{bias}}$  (up to  $\pm 200$  V) to the sample, within the ultra high vacuum chamber of the HECTOR endstation at the BOREAS beamline. In **Figure 4(b)**, we show the raw TEY signal (before normalizing it to the x-ray abosprtion absorption (I<sub>ref</sub>) signal from a Au mesh) for an  $E_{ab}$  polarization, collected at 0 V and  $\pm 200$  V DC. The background current is found to be larger for  $V_{\text{bias}} > 0$  than for  $V_{\text{bias}} < 0$ , because  $V_{\text{bias}}$  applied to the sample affects the drain current measured by the electrometer [more details given in the **Supplementary Information S7**]. Naturally, this variation has no significance when calculating the XLD data because we have normalized the XAS data to the averaged L<sub>3</sub> peak intensity (following a protocol identical to that used in the substrate-induced strain experiments). In **Figures 4(c-e)** we show the La-subtracted Ni L<sub>2,3</sub> XAS using V<sub>bias</sub> = -200 V, 0 V and +200 V, respectively. The integrated intensities were calculated after removing a similar step-function from all the XAS.

In **Figure 5(a)** we show the XLD data obtained from the spectra in **Figures 4(c-e)**. We first note that the XLD spectral features for the L<sub>3</sub> and L<sub>2</sub> edges at  $V_{\text{bias}} = 0$  V are qualitatively similar, apart from the magnitude, to those observed in the 14 nm LNO film on an STO substrate (see the gray colour spectra in **Figure 5(a)**). This confirms that the STO buffer layer induces a tensile strain on the top lying LNO film of the LNO/STO//PMN-PT heterostructure, just like in the 14 nm LNO/STO film. The determined hole ratio  $X \approx 1.04$ ) and the orbital polarization  $P \approx 6$  %) values for the above unbiased sample are depicted in **Figure 5(b)**. Interestingly, the observed X and P values are in between those reported above for 14 nm and 5 nm films on STO (see **Figures 2(b) and 2(a)**), and thus they are fully consistent. The XLD in **Figure 5(a)** varies when applying the  $V_{\text{bias}}$  across the PMN-PT, with a virtually identical response to  $V_{\text{bias}} > 0$  and  $V_{\text{bias}} < 0$ . In both cases, the applied voltage induces a more positive XLD signal. Consistently, we note that when increasing  $|V_{\text{bias}}|$ , irrespective of its polarity, the hole ratio  $X = h_{3z^2-r^2}/h_{x^2-y^2}$  decreases, as shown in **Figure 5(b)**, implying that the  $3z^2-r^2$  electron orbital occupancy increases with the bias.



**Figure 5.** (a) The Ni-L<sub>2,3</sub> XLD of a LNO/STO//PMN-PT film at 0 V and  $\pm$  200 V indicates that  $V_{\text{bias}}$  changes the XLD (by magnitude) and so the orbital occupancy (towards the  $3z^2-r^2$  orbitals). The spectral features of the unbiased sample resembles to those of 14 nm LNO/STO (in gray colour) from the substrate-strain experiment except slight differences in the orbital polarization values (b) Hole occupancy ratio (*X*, left axis) and orbital polarization (*P*, right axis) show an irreversible piezo response with the  $V_{\text{bias}}$ .

In **Figure 5(b)**, the variation of *X* and *P* with  $V_{\text{bias}}$  is shown. Arrows indicate the  $V_{\text{bias}}$  sequence followed in the experiment (0 V  $\rightarrow$  +200 V  $\rightarrow$  0 V  $\rightarrow$  -200 V  $\rightarrow$  0 V). It is observed that  $X(V_{\text{bias}})$  displays a butterfly-like loop. The butterfly-like shape of  $X, P(V_{\text{bias}})$  shown in **Figure 5(b)** is reminiscent of the piezo-response of ferroelectric PMN-PT under the electric field. More precisely, the observed hysteretic response is that expected if the PMN-PT follows a minor loop, thus indicating that  $V_{\text{bias}} = \pm 200$  V is not large enough to push all the ferroelectric domains of PMN-PT along the [001]-direction. This view is confirmed by the direct comparison of the observed XLD( $V_{\text{bias}}$ ) response with the piezo response of a (001) PMN-PT crystal shown and the experimentally observed shifts of the PMN-PT reflections and STO when V-biasing the substrates (**Supplementary information S8**). Therefore, although no direct evidence of the piezo-induced deformation of the LNO layer is available, the observed expansion of the STO layer under bias and the coherent growth of LNO on STO, strongly supports the view that the LNO layer is also piezo-deformed.

Although the minor loops, as mentioned, can be at the origin of the observed hysteresis of XLD( $V_{\text{bias}}$ ), other scenarios could be envisaged. For instance, Levin *et al.* [36] showed that non-symmetrical and non-reversible piezo-deformation of PMN-PT are observed using x-ray diffraction experiments sensitive to the (001) PMN-PT crystal surface (probing about 0.5 µm depth), while reversible piezo-responsive butterfly loops were recorded using reflections probing the bulk of the crystal. It was argued that the different response was due to distinctive domain reconstructions at the crystal surface that produce irreversible deformation (i.e., nonelastic) loops. On the other hand, it has also been reported that cracks, quite counterintuitive, can be reversibly formed in PMN-PT upon polarization switching and they can be transferred to the metallic layers grown onto it. In fact, when the coating layer is a metallic alloy (MnPt), substrate cracks can lead to reversible changes of the resistivity of the ductile metallic films [37]. In the same vein, voltage pulses applied to PMN-PT substrates and subsequent morphologic reconstructions have been shown to promote reversible changes of magnetic and electric properties of ductile metallic  $Fe_xMn_{1-x}$  layers [38]. In the present case, the LNO film is not expected to be ductile and so any morphological reconstruction in the substrate should lead to an irreversible response in the LNO film. All in all, this mechanism will give rise to some hysteretic domain configuration and thus a hysteretic strain distribution acting upon the orbital occupancy of the LNO films.

Here, of higher relevance is the discovery that, under  $V_{\text{bias}}$ , the  $3z^2 - r^2$  electron occupancy is clearly favored in a magnitude tunable by the  $V_{\text{bias}}$ . This observation, together with the butterfly-like response, strongly suggests that the electric field-induced strain is transmitted from the PMN-PT substrate towards the top-lying LNO film. This observation would be consistent with a clamping of LNO onto the STO-buffered PMN-PT substrate, although it should be recognized that we have not direct (structural) evidence of the piezo deformation of the LNO lattice. Accordingly, a voltage-induced expansion of the substrate along the direction of the applied electric field (perpendicular to the crystal plane) shall produce a contraction in its in-plane lattice parameter and thus the LNO film would be in-plane compressed. The field-induced in-plane compression of the substrate is given by  $\Delta a_s/a_s = -d_{31}$ x E, where  $a_s$  is the PMN-PT cell-parameter,  $d_{31}$  is the transverse piezoelectric coefficient and E is the applied electric field. As a result, and in agreement with the data collected on LNO films under different epitaxial strain [Figure 1(c) and Figure 2(a)], the  $3z^2 - r^2$  electron occupancy should be favored, which is fully consistent with the observation. The data in Figure **5(b)** show that the changes in hole and electron orbital occupancies at the largest  $V_{\text{bias}}$  (± 200 V) are:  $\Delta X \approx -2.7 \%$  ( $\Delta X/\Delta \varepsilon = -54 \%/\%$ ) and  $\Delta P \approx 3.9\%$  ( $\Delta P/\Delta \varepsilon = -78 \%/\%$ ). In order to get a better insight into the significance of these relative changes, we replot in Figure 2(b) the observed dependence of (X, P) vs V<sub>bias</sub> (bottom-axis) and the voltage-induced strain ( $\varepsilon$ (V<sub>bias</sub>) =

 $-d_{31} \ge E$  (top-axis) developed by the PMN-PT substrate. In this evaluation, we used  $d_{31} = -1250 \text{ pm/V}$ , as reported for (001) PMN-PT [39]. Assuming that the LNO is clamped to the STO layer and ultimately to the substrate, and the strain is fully transmitted, this evaluation provides the maximal in-plane compressive strain to be expected from PMN-PT. It is important to note that the maximal voltage-induced strain is of only about -0.05 % but the change of polarization is remarkably high (78%/% of  $\Delta P/\Delta \varepsilon$ ), and consequently in **Figure 2(b)**, the slope of  $X,P(\varepsilon(V_{\text{bias}}))$  is exceedingly (about 9 times) larger than the  $X,P(\varepsilon)$ . We shall comment below on this difference.

#### **IV. SUMMARY AND CONCLUSIONS**

We have used XAS and XLD at the Ni-L<sub>2,3</sub> edges to determine the orbital occupancy in LaNiO<sub>3</sub> films. Several conclusions emerge from the data reported here. We have observed that the epitaxially-induced strain effect alone allows for a substantial tuning of the orbital polarization which, however, remains within a modest -16% < P < +8% range. We have also quantified the surface-induced orbital polarization that unavoidably favors the  $3z^2 - r^2$  orbital occupation and thus provides a  $P_{surface} \approx -4\%$  that adds or subtracts, depending on the sign of the strain, to the strain-only contribution. Relying on the existing Ni-O hybridization, consistent deductions have been derived from XAS and XLD at the O-K edges. Finally, we have observed that the electric field-induced strain applied on the PMN-PT substrate, elastically deforms the STO buffer layer by promoting its in-plane compression and enhances the  $3z^2 - r^2$  occupancy in LNO. Therefore, it follows that, although the orbital occupancy can be controlled either ex-situ by an appropriate epitaxial strain or *in-situ* by using piezoelectric substrates, the voltagecontrolled strain can only favor the  $3z^2 - r^2$  occupancy rather than the  $x^2 - y^2$  occupancy required to emulate cuprate HTSc. On the other hand, the intriguing observation that the change of orbital occupancy using a V-biased ferroelectric substrate is much larger than expected on the basis of pure elastic effects at first sight may suggest that electronic reconstructions, including charge-transfer may remain, although blurred by the STO spacer. Indeed, it has been reported that at the interface between LNO and ferroelectric BaTiO<sub>3</sub> [40] or PZT [41], a subtle charge transfer may occur, that may result in a change of orbital polarization. However, in those cases the observed effects were found to reverse when reversing the sign of the polarization. This is in contrast with our data of Figure 5(b), where an almost voltage-symmetric effect is observed. This strongly supports the view that the observed voltage-induced large sensitivity of orbital polarization is associated with the compression/expansion of the piezo substrate. A simple hypothesis that could account for this observation is to recall the rhombohedral nature of LNO and the fact that the NiO<sub>6</sub> octahedra are linked by Ni-O-Ni bonds having a bond angle  $\theta \approx 150^{\circ}$ [4]. As the LNO lattice is coherently grown on STO//PMN-PT, a compression/expansion of the substrate unit cell under voltage biasing could translate into a modification of the Ni-O-Ni bond lengths and angles. Nevertheless, as mentioned, assuming the known bulk values of the piezoelectric coefficient of PMN-PT(001), it appears that voltage-induced strain has a larger effect on orbital polarization than epitaxial strain. It may be argued that, in agreement with early data, the elastic properties of PMN-PT surface differ from those of the bulk. However, it cannot be excluded that epitaxial strain, established during film growth at high temperature, has a different impact on bond topologies than *in-operando* piezo-substrates. Finally, we have shown that an electric field applied along the [001] direction on PMN-PT(001) unavoidably favors the  $3z^2 - r^2$  orbital occupation. To reverse orbital occupancy towards  $x^2 - y^2$ , piezoelectric substrates with smaller in-plane parameters that may impose compressive strain on LNO, explore different substrate orientations or even using pre-grown free standing LNO films anchored to the piezo substrates, can be viable alternative routes worth to explore.

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